

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Wen-Ben CHOU et al.

Application No: 09/998,855

Filed: October 31, 2001

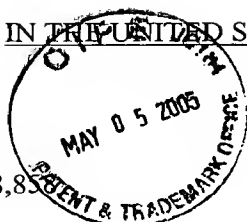
For: METHOD AND APPARATUS FOR NITRIDE
IN SITU SPACER ETCH PROCESS
IMPLEMENTING INTERFEROMETRY
ENDPOINT DETECTION AND NON-
INTERFEROMETRY ENDPOINT MONITORING

Attorney Docket No: LAM2P295

Examiner: Chen, Kin Chan

Group Art Unit: 1765

Date: May 2, 2005



CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Attn: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on May 2, 2005.

Signed:

Fariba Yadegar-Bandari

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Request for Reconsideration in the above-identified Application.
The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE ENTITY RATE FEE
TOTAL CLAIMS	24	25	00	X 25 = \$ 0.00	OR	X 50 = \$ 0.00
INDEP CLAIMS	06	08	00	X100 = \$ 0.00 \$180	OR	X200 = \$ 0.00 \$360
[] Multiple Dependent Claim Present and Fee Not Previously Paid						

TOTAL \$ 0.00

\$ 0.00

☐ Applicant(s) hereby petition for a ____ month(s) extension of time to respond to the outstanding Office Action.

☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805.

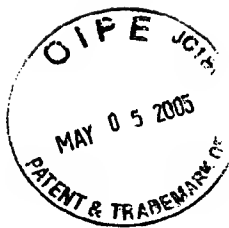
☐ Enclosed is our Check No. _____ in the amount of \$ _____ to cover the additional claim fee and/or extension of time fees.

☒ If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P295). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE PENILLA & GENCARELLA, LLP

Fariba Yadegar-Bandari, Esq.
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)	
)	Docket No. LAM2P295
Wen-Ben CHOU et al.)	
)	Examiner: Chen, Kin Chan
Application No. 09/998,858)	
)	Group Art Unit: 1765
Filed: October 31, 2001)	
)	Date: May 2, 2005
For: METHOD AND APPARATUS)	
FOR NITRIDE SPACER ETCH)	
PROCESS IMPLEMENTING -)	
IN SITU INTERFEROMETRY)	
ENDPOINT DETECTION AND)	
NON-INTERFEROMETRY)	
ENDPOINT MONITORING)	

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Signed: _____

Fariba Yadegar-Bandari

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR RECONSIDERATION

Dear Sir:

The subject Request for Reconsideration is in response to the Office Action mailed on January 31, 2005. Please enter the following remarks in the above-identified patent application:

The Listing of Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.